

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

AF
IFW

Applicant: Gurtej S. Sandhu et al.

Title: CHEMICAL VAPOR DEPOSITION OF TITANIUM

Docket No.: 303.676US2

Serial No.: 09/940,917

Filed: August 28, 2001

Due Date: October 12, 2004

Examiner: Mary Wilczewski

Group Art Unit: 2822

MS AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

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☒ A return postcard.

☒ A Response under 37 CFR 1.116 (11 Pages).

Please consider this a **PETITION FOR EXTENSION OF TIME** for sufficient number of months to enter these papers and please charge any additional fees or credit overpayment to Deposit Account No. 19-0743.

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.

Customer Number 21186

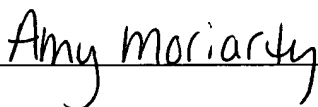
By: 

Atty: David C. Peterson

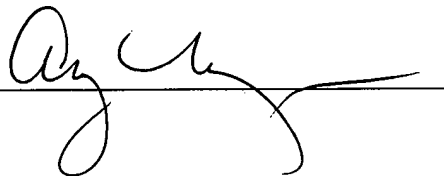
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CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to: MS AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this 30th day of September, 2004.

Name



Signature



SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.

(GENERAL)



EXPEDITED PROCEDURE – EXAMINING GROUP 2822

S/N 09/940,917

PATENT

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RESPONSE UNDER 37 C.F.R. 1.116

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

In response to the Final Office Action mailed August 12, 2004, please consider the following remarks: